

U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					M-12291 US		10/020,452	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant:			
(Use several sheets if necessary)					Cauchi, John			
					Filing Date		Group 1756	
					12/14/01		Unknown	

  

U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
KMD	AA	6,301,008 B1	10/09/01	Ziger et al.	356	401	
KMD	AB	6,311,319 B1	10/30/01	Tu et al.	716	19	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

  

Foreign Patent Documents							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

  

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
KMD	AQ	Handbook of Microlithography, Micromachining, and Microfabrication; Volume 1: Microlithography, Editor P. Rai-Choudhury; (1997), page 79
	AR	
	AS	

  

Examiner	K. Duda	Date Considered	5-30-03
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KMD	AA	5,631,112	05/20/97	Tsai et al.	430	22		
	AB	5,663,893	09/02/97	Wampler et al.	364	491		
	AC	5,863,712	01/26/99	Von Bunau et al.	430	396		
KMD	AD	6,280,887	08/28/01	Lu	430	5		
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
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